

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/719,807	WEI ET AL.	
Examiner	Art Unit	
RAJ K. JAIN	2616	

	SEARCHED		
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
interferen	ce search	4/16/2008	RJ	

SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
East, Inventor search.	8/15/2003	RJ
370/342,343,344,345,335,319,320.	8/15/2003	RJ
375/130,133,140,141,149.	8/15/2003	RJ
Updated search	11/2/2007	RJ
updated search 455/\$	4/16/2008	RJ